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## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

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ELG056-US	10/720,421
Applicant:	
Kent et al.	
Filing Date:	Group:
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Exr. initial	Details of Document	Translation enclosed (?)
	International Search Report for International Application No. PCT/US2004/038348, dated July 21, 2005.	
	International Search Report for International Application No. PCT/US2004/038349, dated July 21, 2005.	
	Richard Friend et al., "Polymer Diodes", <u>Physics World</u> , Bristol, Great Britain, vol. 12, no. 6, June 1999, pages 35-40.	
	L.S. Roman et al., <u>Appl. Phys. Lett.</u> , vol. 75, 1999, pages 3557-3559.	
	G. Greczynski et al., <u>Thin Solid Films</u> , vol. 354, 1999, pages 129-135.	
	L.S. Roman et al., <u>Synth. Metals</u> , vol. 125, 2002, pages 419-422.	
	Patent Abstracts of Japan, vol. 008, no. 190 (E-263), 31 August 1984 & Japanese Publication No. JP 59-078584 A (Toshiba KK), 7 May 1984 (abstract only)	

Examiner's signature

Date considered

\* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.